

U.S.S.N. 10/050,322

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tsai et al.

Group Art Unit: 1756

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Serial No.: 10/050,322

Examiner: N. M. Barreca

Filed: 01/15/2002

In Response to Office Action  
Dated: 04/13/2005For: A BI-LAYER PHOTORESIST DRY DEVELOPMENT AND REACTIVE  
ION ETCH METHOD

Attorney Docket No.: 67,200-613

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certify that this correspondence is (1)  being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on October 28, 2005; or (2)  being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571) 273-1379 on October 28, 2005.

Randy W. Tung  
Printed Name

Signature

10/28/05  
Date

Please forward all correspondence to  
TUNG & ASSOCIATES  
838 W. Long Lake Road, Suite 120  
Bloomfield Hills, MI 48302

STATEMENT OF COMMON OWNERSHIP PURSUANT TO 35 USC 103(a)

Applicants' attorney of record state that Tsai et al. (6,787,455) and Applicants' instant application were, at the time the invention was made, owned by Taiwan Semiconductor Manufacturing Company. Therefore, Examiners use of Tsai et al. as a reference in a 103(a) rejection appears to be improper under 35 USC §103(C).

Respectfully submitted,  
TUNG & ASSOCIATES, PLL

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08-02-05 10:36 FROM-TUNG & ASSOCIATES

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T-413 P02/14 U-662

U.S.S.N. 10/050,322

**Second SUPPLEMENTAL AMENDMENT**

Assistant Commissioner  
for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 07/07/2005 please  
allow entry of the following amendments to place the Application  
in better form for Appeal.

OK  
to enter  
now

11/26/04